

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shinji Maekawa Art Unit : 2813  
Serial No. : 09/724,403 Examiner : Stephen W. Smoot  
Filed : November 27, 2000 Confirmation No.: 7575  
Notice of Allowance Date: February 14, 2007  
Title : METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE THAT  
INCLUDES FORMING A MATERIAL WITH A HIGH TENSILE STRESS IN  
CONTACT WITH A SEMICONDUCTOR FILM TO GETTER IMPURITIES  
FROM THE SEMICONDUCTOR FILM (AS AMENDED)

**MAIL STOP ISSUE FEE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO NOTICE OF ALLOWANCE**

In response to the Notice of Allowance mailed February 14, 2007, enclosed are a completed issue fee transmittal form PTOL-85b and a check for \$1400 for the required issue fee and publication fee, including patent copies.

Please apply any additional charges or credits to our Deposit Account No. 06-1050.

Respectfully submitted,

Roberto J. Devoto  
Reg. No. 55,108

Date: 7/17/01

Fish & Richardson P.C.  
1425 K Street, N.W.  
11th Floor  
Washington, DC 20005-3500  
Telephone: (202) 783-5070  
Facsimile: (202) 783-2331